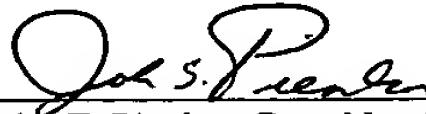


2-26-02 2892

PATENT

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date set forth below as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231.

Date of Signature  
and Deposit: January 29, 2002

  
John T. Pienkos, Reg. No. 42,997

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Mark A. Lucak  
Application No.: 09/843,563  
Filed: April 26, 2001  
For: METHOD FOR FABRICATING A  
MICROELECTROMECHANICAL SYSTEM  
(MEMS) DEVICE USING A PRE-PATTERNEDE  
SUBSTRATE  
Group Art Unit: 2812  
Examiner: --  
Atty. Docket No.: 110003.97427

**INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. §§1.97 AND 1.98**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

This paper is being presented for filing in the above case pursuant to Rules 97 and 98 of the Rules of Practice. A Form PTO-1449 "Information Disclosure Statement by Applicant" is attached which lists the references cited and copies of the references are enclosed.

No additional fees for filing this paper are believed to be due. However, the Commissioner is hereby authorized to charge any additional fees due or to credit any overpayment to deposit account no. 17-0055.

Respectfully submitted,

  
John T. Pienkos  
Reg. No. 42,997  
Quarles & Brady LLP  
411 East Wisconsin Avenue  
Milwaukee, WI 53202-4497  
(414) 277-5777